effice petition IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

KOZAWA et al.

Attorney Docket No: 100021-

00065

Application No. 10/005,347

Art Unit: 1712

Filed: December 7, 2001

Examiner: K. Peng

For:

SILICON-CONTAINING POLYMER, PROCESS FOR ITS PRODUCTION, RESIST COPOSITION EMPLOYING IT, PATTERN-FORMING METHOD

AND ELECTRONIC DEVICE FABRICATION METHOD

PETITION TO WITHDRAW PATENT APPLICATION UNDER 37 CFR 1.313

Mail Stop: Petitions Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: May 9, 2005

Sir:

Applicant petitions to withdraw the above referenced patent application from issue after payment of the issue fee to permit consideration of an information disclosure statement under 37 C.F.R. § 1.97 in a request for continued examination as permitted by 37 C.F.R. §1.313(c)(2).

A check in the amount of \$130.00 as set forth in 37 CFR 1.17(i) is enclosed. If any further fee is due to effect grant of this Petition, the U.S. Patent and Trademark Office is authorized to charge Deposit Account No. 01-2300.

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It is respectfully submitted that the requirements of 37 CFR 1.313 are satisfied.

Respectfully submitted,

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RKC:tdd